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## Bib Data Sheet

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## \*\* CONTINUING DATA \*\*\*\*\*

*len none*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-221929 07/30/2002

*len none*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after allowance	JAPAN	11	17	4
Verified and Acknowledged	Examiner's Signature <i>allc</i>	Initials			

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## TITLE

Ion beam apparatus, ion beam processing method and sample holder member

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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